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17410 U.S. PRO
10/612394
07/03/03

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Application of Hironori ENDO
LIQUID EJECTION CONTROL METHOD AND LIQUID EJECTION
APPARATUS
Assignee: **SEIKO EPSON CORPORATION**
Our Ref. Q76423

Dear Sir:

Attached hereto is the application identified above comprising forty-six (46) sheets of the specification (Japanese Language), including the claims and abstract and twelve (12) sheets of drawings. **The requisite U.S. Government filing fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.**

The Government filing fee is calculated as follows:

Total claims

Independent claims

Base Fee

TOTAL FEE

$\frac{19}{1} - \frac{20}{3}$

$= \frac{\quad}{\quad} \times$
 $= \frac{\quad}{\quad} \times$

\$18.00
\$84.00

=
=

\$0.00

\$0.00

\$750.00

\$750.00



SUGHRUE MION, PLLC

MAIL STOP PATENT APPLICATION

Attorney Docket No. **Q76423**

Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2002-197598	July 5, 2002
Japan	2002-286930	September 30, 2002

The priority documents are enclosed herewith.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

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WASHINGTON OFFICE



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PATENT TRADEMARK OFFICE